02-01-0,6

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor:

Hiroshi OKUMURA

Serial No.:

10/615,670

Filed:

July 8, 2003

Title:

METHOD OF FORMING SEMICONDUCTOR THIN-FILM

AND LASER APPARATUS USED THEREFORE

Examiner:

Samuel M. Heinrich

Group Art Unit:

1725

Confirmation No.:

9827

Attorney Docket No.: 100806-00215 (NECA 20.494)

January 31, 2006

Mail Stop AF Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

SIR:

Applicant requests that the time for taking action in this case be extended pursuant to 37 CFR 1.136(a) for:

[] one month	[]	four months
] two months	[]	five months
[]	X1 three months		

The fee set in 37 CFR 1.17 for the extension of time is \$1020.00.

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App. Serial No.: 10/615,670

[Deposit A	Fee enclosed. In Account No. 50-12	Please charge any addit 90. A duplicate copy of	tional fee ro	equired for thi	is extension o	f time to	
[X enclosed.	[X] Charge fee to	Deposit Account No.	50-1290.	A duplicate	copy of this	paper is	
Al	Also enclosed is a:						
]] RCE] Notice of Appea	[X] Response					

Respectfully submitted,

Brian e. Hennessey Reg. No. 51,271

CUSTOMER NUMBER 026304 Telephone: (212) 940-8800 Fax: (212) 940-8986/8987

Docket No.: 100806-00215(NECA 20.494)

BEH: pm